



Docket No. 740756-2045

In re Patent Application of:)
Inventor's name(s): Kenji ITOH et al.) Group Art Unit: 1762
Serial No. 09/412,510) Examiner: M. Padgett
Filed: October 5, 1999)
For: PROCESS FOR TREATING A) Date: September 12, 2001
SUBSTRATE WITH A PLASMA)

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on September 12, 2001.

[mailer's name]

AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Final Office Action dated May 11, 2001 and further to the attached Request for Continued Examination (RCE), please amend the above identified application as follows.

IN THE SPECIFICATION:

Please delete the first sentence of the specification and insert --This application is a divisional of U.S. Application Serial No. 08/604,713, now U.S. Patent No. 6,001,431, filed February 21, 1996, which itself is a continuation of U.S. Appln. Serial No. 08/173,961, filed December 28, 1993, now abandoned.--

IN THE CLAIMS:

Please cancel claims 1, 18, and 19 without prejudice or disclaimer.

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